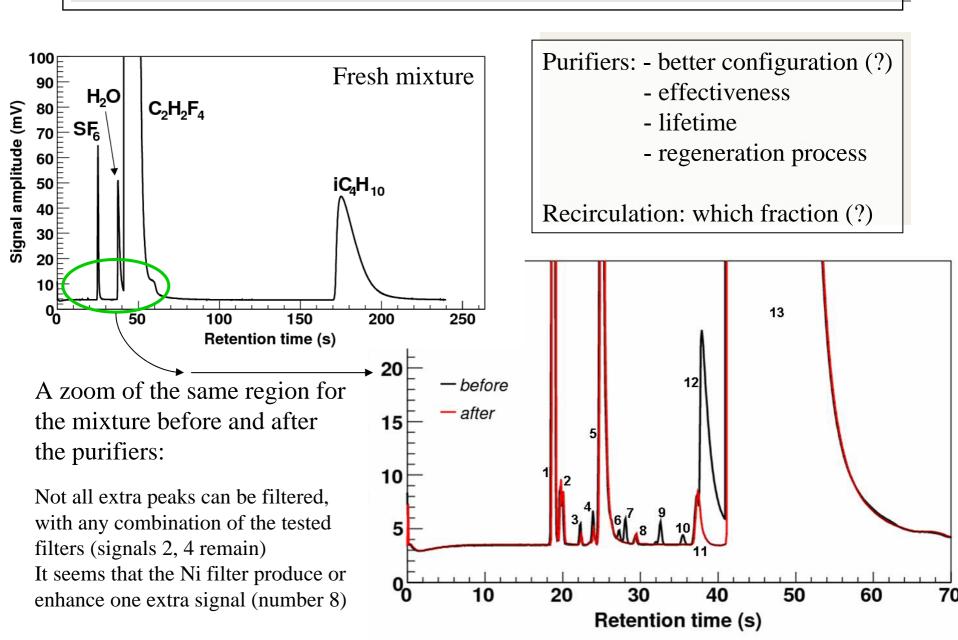
# Studies of Purification of the LHC RPC Gas Mixture

Status June 08

RG, MC, IG

## Open issues from the 2000-2004 GIF ageing test



## Open issues from the 2006-2008 ISR test

#### RPCs:

- •Real size CMS-RPC part of the normal production
- •7 old DG (CMS-RB1) connected:
  - -) 1 in open mode
  - -) 6 in closed mode
- •10 new SG
- •Temperature and Relative Humidity (Environmental + mixture) under control

Gas flow: 1 volume change / 2.5÷3 hour HV constantly on at operating value (9.6 kV @ 1020 mbar)

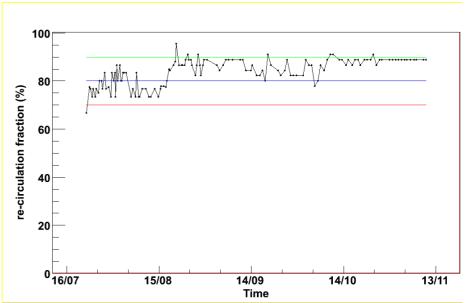
No radiation (cosmic ray only )

#### Gas re-circulation:

Test started with a re-circulation factor of about 70 %

After one month re-circulation increased Since middle October stable at 90 %



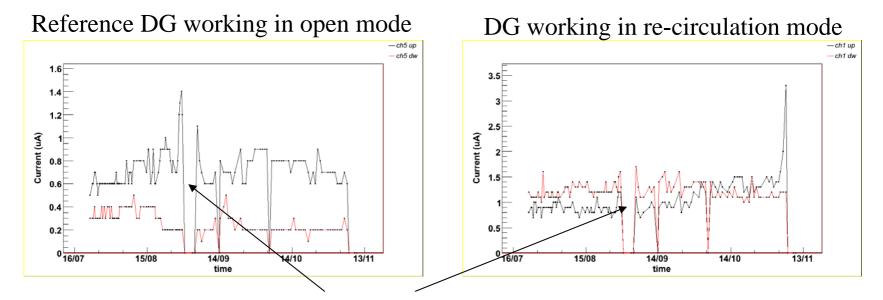


#### Example from a test cycle

All the DGs were stable operated for about 3 months

If the "air" concentration in the mixture is much greater than 500 ppm the performance (i.e. current) starts to be affected

Beginning of November: sudden increase of the current in all the DG operated in closed loop mode (particularly evident for the gap up)



Abnormal "air" level in the mixture (due to R134a cylinder impurity)

→ RPCs switched off

# Objectives

- Understanding RPC-irradiated gas mix
  - Concentration of impurities
  - Identification of harmful impurities
- Systematic understanding of purifier agents
  - Filters capacity, efficiency
  - Overall lifetime
  - Optimal filter combination, etc
  - Try new filters?
- Final optimization of LHC closed-loop gas systems operation

## Set-up (status June 2008)

- Main users of GIF till end of 2008, possibly 

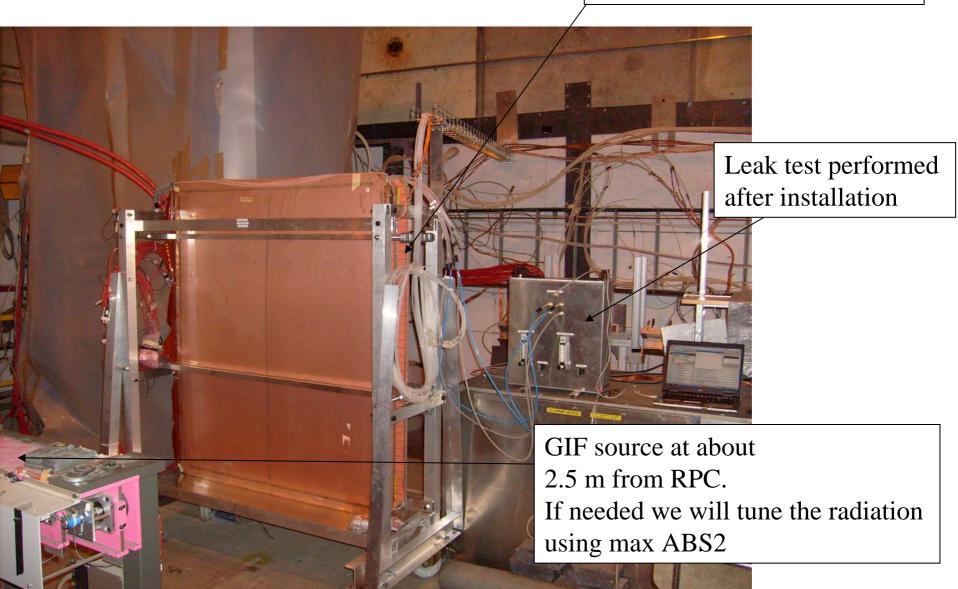
   also in 2009
- Set-up:
  - 5 (+1) CMS Double Gaps (HV P.S, SW, etc) ✓
  - Refurbished ATLAS GIF Gas system
  - new Filters rack
  - Gas Analysis: GC/MS
  - Fluoride measurement





#### **Detectors**

5 (+1) CMS-RPC double gap



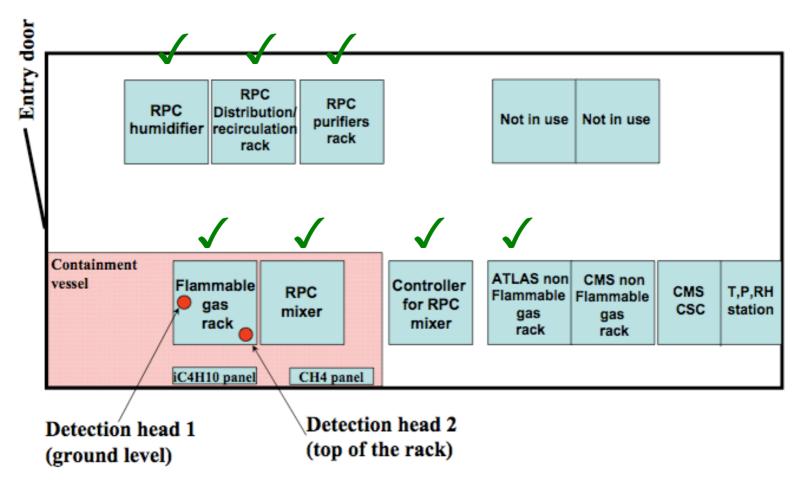
#### High voltage system



The high voltage system is just outside the radiation area.

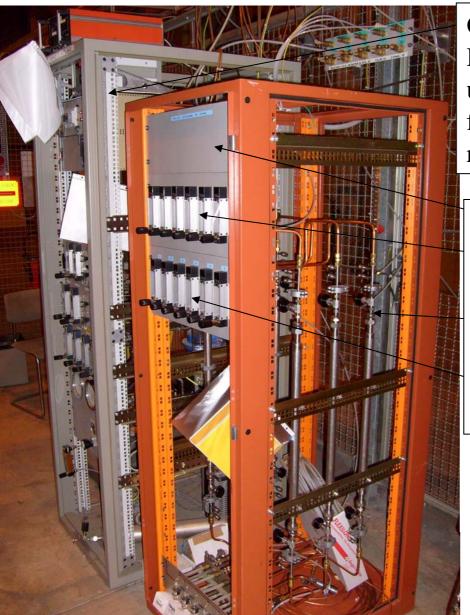
SY1527 + 2 HV modules + HV cables have been provided by CMS

## Gas System Racks Layout



- •All pipes and racks have been tested for leak tightness (30' at constant P)
- Pipes from gas panel to chambers inside GIF and return are new (rilsan)
- •When needed, (many) rubber joints have been replaced

#### Gas system



Gas re-circulation rack (from ATLAS). During the first phase of the test we will use the system in open mode. The gas from the RPC will be send to the filters rack and then vented.

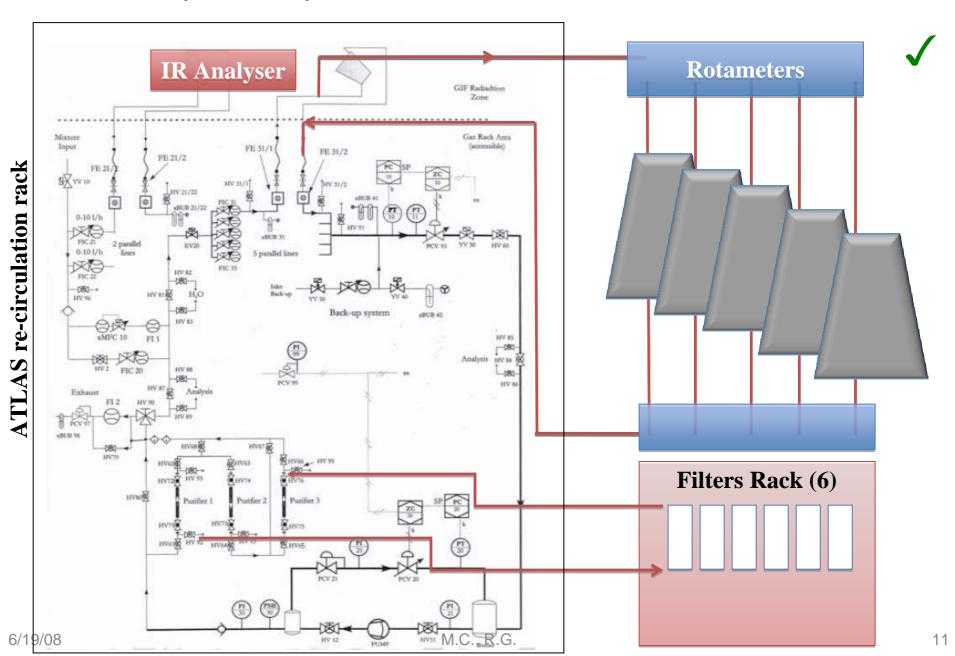
Filters rack (PH-DT).

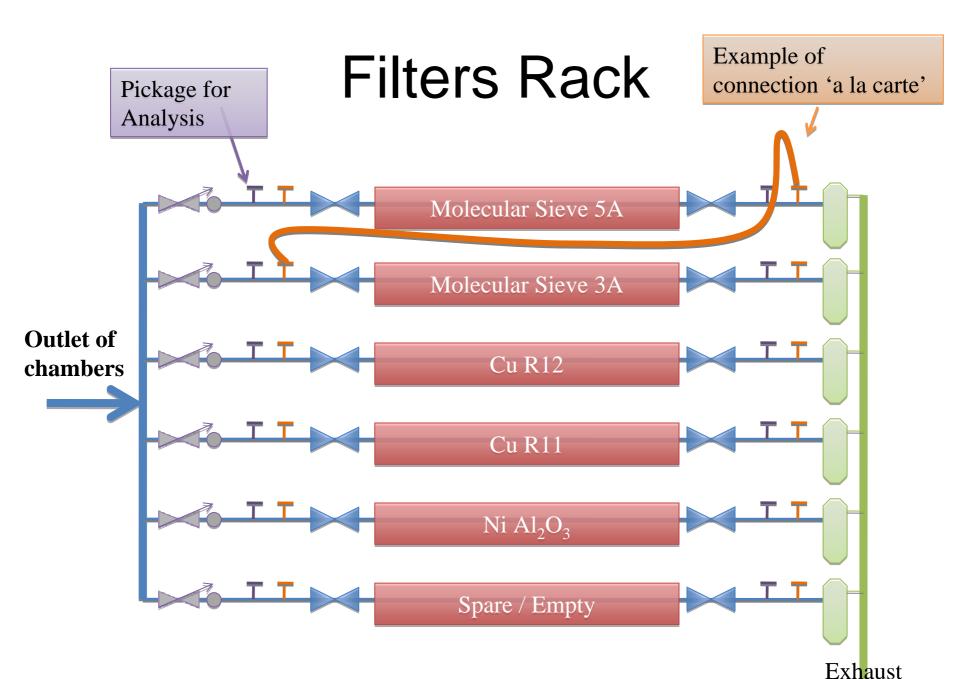
6 rotameters for the gas distribution to the chambers

6 cartridges with different purifier agents

6 rotameters for the gas distribution to each cartridge

#### Gas system layout





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## Status of the test

- Checked chamber performance with radiation → June-July ✓
- 2. Make reference Bakelite resistivity measurements → July ✓
- Set-up F-measurement and scan HF concentration for different concentrations of iC4H10 and SF6 → July ✓
- Study of the production of other impurities as a function of the gas mixture composition → August
- Perform detailed gas analysis of every filter individually (comparison fresh mixture vs purified mixture) → September

# Status and planning

- 6. Split the return gas into the different purifier agents and start the study of the lifetime for several cycles (6-10 regenerations) → October June
- 7. Test of possible new material (more specific for the identified impurities) → October June
- 8. Start to test the old and new purifier configurations in closed loop circulation → June-December

## Analysis of fluoride and other impurities

We are studying the production rate of F- and other impurities in order to verify if a small change in the mixture composition can produce a significant reduction of the production rate.

tot Flow:	C2H2F4	iC4H10	SF6	date start	date end	8800	9000	9200	9400	9600	9800	
(l/h)	(%)	(%)	(%)			(V)	(V)	(V)	(V)	(V)	(V)	
40	96.35	3.5	0.15									
40	96.2	3.5	0.3					· ·	· 	_		
40	30.2	0.5	0.0						Ξ_)	_		
40	95.9	3.5	0.6				V		· <del>-</del> /	_		
40	94.85	5	0.15									
40	94.7	5	0.3					•				
40	34.1	3	0.5				<ul><li>On going</li><li>-</li></ul>					
40	94.4	5	0.6				with GC-MS for					
40												
40	92.85	7	0.15			— other impurities —						
40	92.7	7	0.3								_	
40	92.4	7	0.6									

## Fluoride study

The F- production rate is measured with two different techniques: ISE and HPLC

Ion Selective Electrode for F-:
On-line measurement
(now with a double channel station)

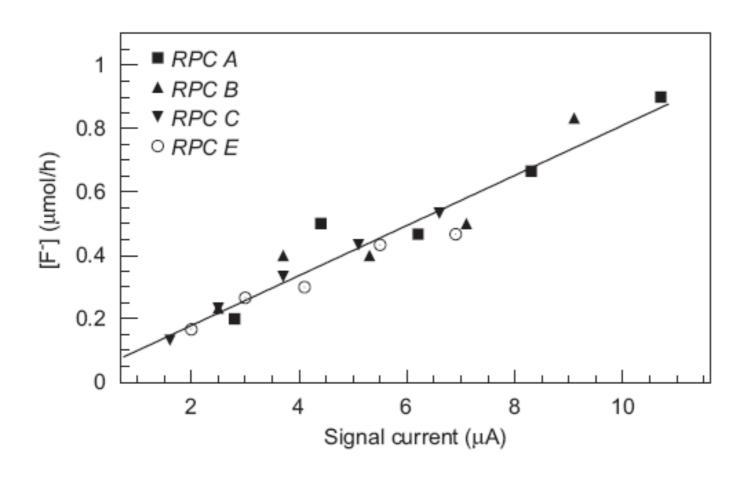


High Performance Liquid Chromatography: Cross check + will allow to spot-out other impurities

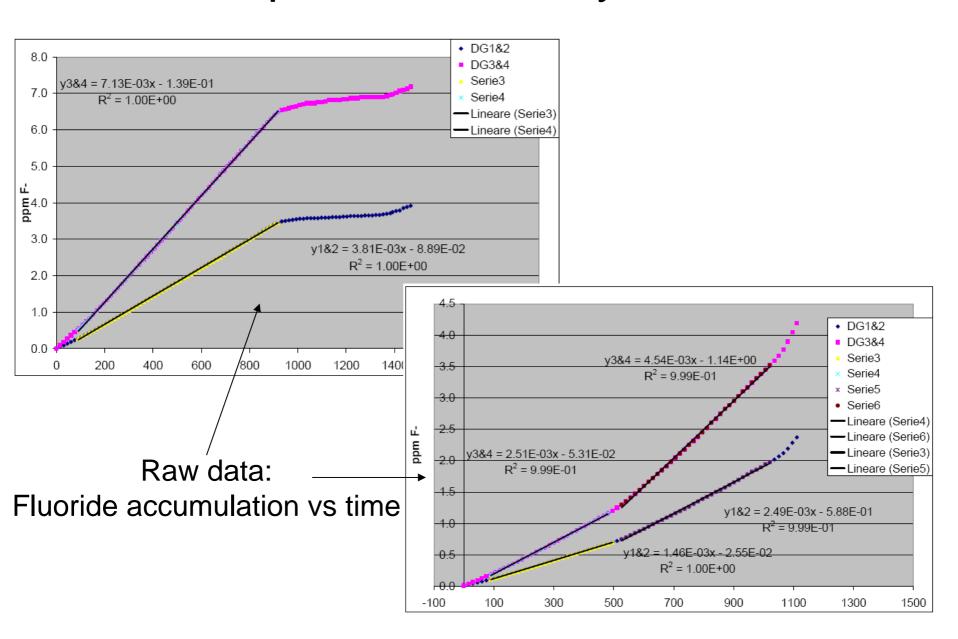


## Fluoride study

Results from CMS GIF ageing test (R.Guida et al., Nucl. Instr. and Meth. A (2008), doi:10.1016/j.nima.2008.06.009)

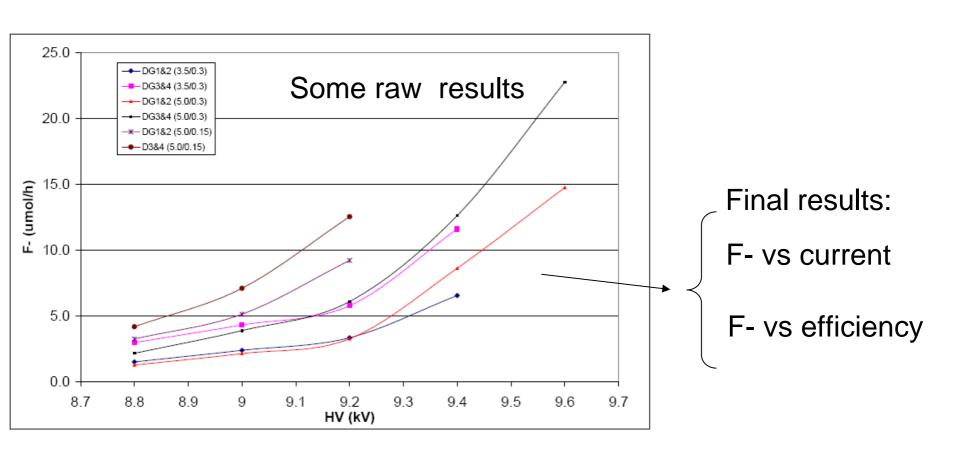


## Fluoride production study: new results

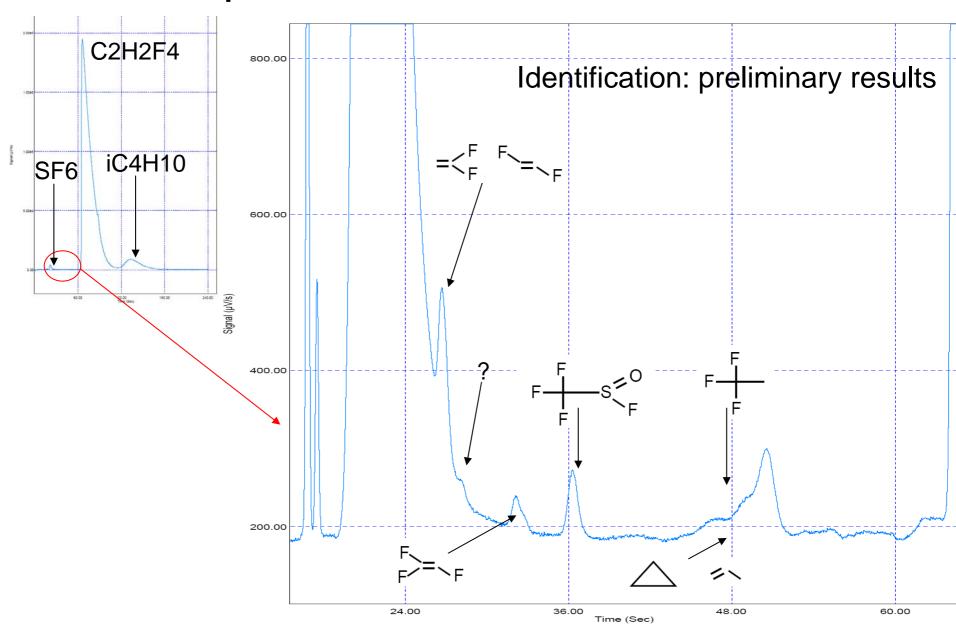


## Fluoride production study

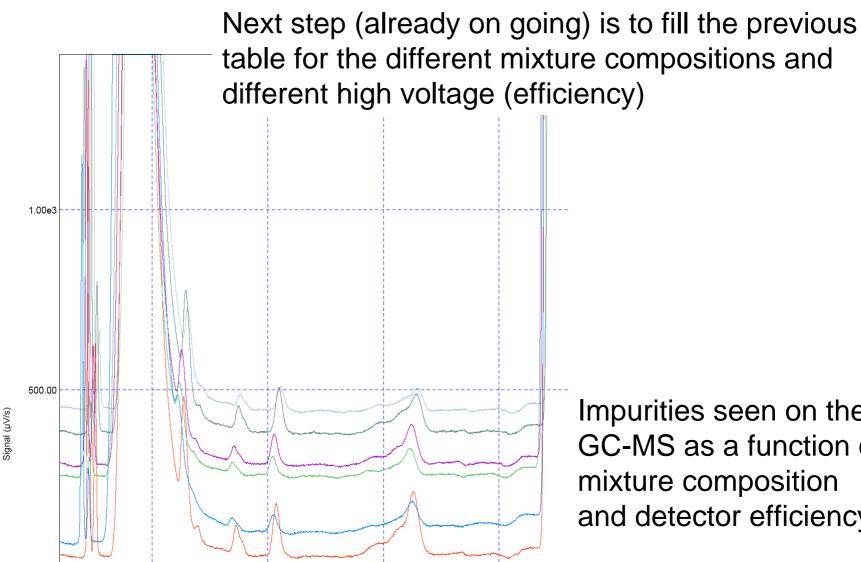
Fluoride production rate vs detector high voltage:



## Impurities found with GC-MS



## Other impurities with GC-MS



Impurities seen on the GC-MS as a function of mixture composition and detector efficiency